

**Reply under 37 CFR 1.116**  
**Expedited Procedure - TC 1762**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application Serial No. .... 09/805,620  
Confirmation No. .... 3004  
Filing Date ..... March 13, 2001  
Inventor ..... Craig M. Carpenter  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 1762  
Examiner ..... Kelly M. Stouffer  
Attorney's Docket No. .... MI22-1563  
Customer No. .... 021567  
Title: ..... Chemical Vapor Deposition Methods (Amended)

**RESPONSE TO JULY 25, 2007 FINAL OFFICE ACTION**  
**UNDER 37 CFR 1.116(b)**

To: MS AF  
Commissioner for Patents  
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**AMENDMENTS**